



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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TC 1700

In Re Application of: )  
 )  
Han-Ming Wu et al. )  
 )  
U.S. Serial No: 09/823,528 )  
 )  
Filed: March 30, 2001 )  
 )  
For: SHIELDING PLATE IN PLASMA FOR )  
UNIFORMITY IMPROVEMENT )

Examiner: Ram N. Kackar  
Art Unit: 1763

MAIL STOP NON-FEE AMENDMENT  
Commissioner for Patents  
U.S. Patent and Trademark Office  
P.O. Box 1450  
Alexandria, Virginia 22313-1450

**AMENDMENT AND RESPONSE TO OFFICE ACTION**

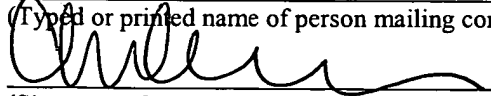
Sir:

In response to the Office Action mailed August 12, 2003, applicants respectfully request that the above-identified application be amended as follows:

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I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450 on November 10, 2003.

Christine Donahue  
(Typed or printed name of person mailing correspondence)

  
(Signature of person mailing correspondence)